	Application No.	Applicant(s)
Notice of Allowability	10/565,676	IIZUKA, HACHISHIRO
	Examiner	Art Unit
	KEATH T. CHEN	1792
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to <u>03/24/2008</u> .		
2. X The allowed claim(s) is/are <u>1-3,5-8,10-17,19 and 20</u> .		
3.		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal F 6. ☐ Interview Summary Paper No./Mail Da 7. ☐ Examiner's Amend 8. ☑ Examiner's Statement 9. ☐ Other	(PTO-413), te

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3.

Allowable Subject Matter

1. Claims 1-3,5-8,10-17,19 and 20 are allowed.

2. The following is a statement of reasons for the indication of allowable subject matter:

valve at the outlet of processing chamber (#338), but does not fairly teach a valve at the draining

Independent claim 1: '085 teaches a valve near the injection nozzle (Fig. 2, #204) and a

portion of the vaporizer. '839 teaches that the outlet valve can be integrated with the vaporizer

(col. 10, lines 2-3, moving #100 into the chamber in Fig. 11). The prior art as a whole does not

fairly teach or suggest to surround/encircle the valve body with a filter.

4. Independent claim 13: '085 teaches the integration of vaporizer with the lid of the

processing chamber as shown in Fig. 2. The prior art as a whole does not fairly teach or suggest

a protrusion defining a sidewall of the vaporizing chamber is formed on the upper plate and the

narrow passageway is formed between a top surface of the protrusion and an inner surface of the

cap.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to KEATH T. CHEN whose telephone number is (571)270-1870.

The examiner can normally be reached on M-F, 8:30-5:00 EST.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Michael Cleveland can be reached on 571-272-1418. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/K. T. C./ Examiner, Art Unit 1792

/Michael Cleveland/

Supervisory Patent Examiner, Art Unit 1792